

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date . October 3, 2003

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING METHOD,  
AND SEMICONDUCTOR MANUFACTURING APPARATUS

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired September 3, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 147076 in the amount of \$110.00 in payment for:

  X   Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
       Extension fee for response within second month pursuant to §1.136(a) (\$420.00)  
       Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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110.00 DP

Respectfully submitted,



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Please grant any extension  
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